

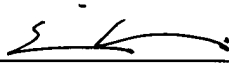
**REMARKS**

By this Preliminary Amendment new claims 46-77 have been added to recite additional protection to which Applicants are entitled. Claims 1-77 are now pending in the present application, of which claims 1, 10, 46-49 and 66-67 are independent.

Applicant also respectfully requests a copy of reference V, *Lurng, Shehng Lee; Chung Len Lee, Argon Ion-Implantation on Polysilicon or Amorphous-silicon for Boron penetration Suppression in p/sup+/pMOSFET, Electron Devices, IEEE Transactions on, Volume: 45 Issue: 8, Aug. 1998, pages 1737-1744* cited on the PTO-892 with the Notice of Allowance.

These claims are believed to be in condition for allowance, however, should the Examiner believe that anything further would be desirable to place this application in better condition for allowance, the Examiner is invited to contact Applicant's undersigned attorney at the telephone number listed below.

Respectfully submitted,

  
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